



DECLARATION - USA PATENT APPLICATION

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name;

I believe I am an original, first and joint inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled a METHOD OF FORMING SILICON-CONTAINING INSULATION FILM HAVING LOW DIELECTRIC CONSTANT AND LOW FILM STRESS of which was filed on August 20, 2003 as Application Serial No. 10/644,195;

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above;

I acknowledge the duty to disclose information which is material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56;

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful, false statements may jeopardize the validity of the application or any patent issued thereon.

Full name of first inventor: Yasuyoshi Hyodo
Inventor's signature
Inventor's signature 14/000 Date 25 th September, 2003
Residence: 23-1, 6-chome, Nagayama, Tama-shi, Tokyo 206-0025 Japan
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Full name of second inventor: Nobuo Matsuki
Inventor's signature Malassa
Date 25th September
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Full name of third inventor: Masashi Yamaguchi
Inventor's signature 17 1 1 1
Inventor's signature 1 1 I F Date 25 day September, 2003
Residence: 23-1, 6-chome, Nagayama, Tama-shi, Tokyo 206-0025 Japan
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Full name of fourth inventor: Atsuki Fukazawa
Inventor's signature
Inventor's signature Date 25 day September, 2003
Residence: 23-1, 6-chome, Nagayama, Tama-shi, Tokyo 206-0025 Japan
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Full name of fifth inventor: Naoki Ohara
Inventor's signature
Inventor's signature 25 day September, 20.3
Residence: 23-1, 6-chome, Nagayama, Tama-shi, Tokyo 206-0025 Japan
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Full name of sixth inventor: Yijun Liu

Inventor's signature

Date 9/25/03

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